

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor(s) : Franz LAERMER et al.
Serial No. : 10/524,610
Filed : August 11, 2005
For : LAYER SYSTEM HAVING A SILICON LAYER AND A
PASSIVATION LAYER, METHOD FOR CREATING A
PASSIVATION LAYER ON A SILICON LAYER AND ITS
USE
Examiner : Hoang Ho
Art Unit : 2818
Confirmation No. : 9981

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

I hereby certify that this correspondence is being electronically transmitted to the United States Patent and Trademark Office via the Office electronic filing system on April 7, 2010.

Signature: /Kevin Kambo/
Kevin Kambo

AMENDMENT

S I R:

In response to the Office Action of January 11, 2010, for which the three-month response date expires on April 11, 2010, kindly amend the above-captioned application without prejudice as follows:

Amendments to the Claims are reflected in the listing of claims, which begins on page 2 of this paper.

Remarks begin on page 5 of this paper.

While no fees are believed to be due, the Commissioner is authorized, as appropriate and/or necessary, to charge any fees or credit any overpayment to **Deposit Account No. 11-0600**.